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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hidemasa KAI**

Art Unit: 1763

Application Number: **10/626,675**

Examiner: **Ram N. Kackar**

Filed: **July 25, 2003**

Confirmation Number: **1831**

For: **EPITAXIAL WAFER PRODUCTION APPARATUS AND
SUSCEPTOR STRUCTURE**

Attorney Docket Number: **030901**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCESSING REQUESTED

Mail Stop: AF
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

June 28, 2007

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RK

Sir:

This paper is filed in response to the Office Action dated April 4, 2007.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.